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	Application No.	Applicant(s)
	09/198,849	KANEYAMA, YOSHINOBU
Notice of Allowability	Examiner	Art Unit
	M. Alexandra Elve	1725
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in) or other appropriate commu RIGHTS. This application is s	this application. If not included inication will be mailed in due course. THIS
1. \boxtimes This communication is responsive to <u>2/4/04</u> .		
2. 🔀 The allowed claim(s) is/are <u>10-19,21,22 and 25-52</u> .		
3. $igotimes$ The drawings filed on <u>24 November 1998</u> are accepted by	the Examiner.	
4. Acknowledgment is made of a claim for foreign priority ca) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 3. Certified copies of the priority documents 4. Copies of the prio	e been received. The been received in Application occuments have been received. The occuments have been received of this communication to file MENT of this application. The occupant of the attached EXAMERS reason(s) why the oath of the submitted. The occupant occupant of the header according to 37 CF osit of BIOLOGICAL MATERS.	In No If in this national stage application from the drawings in the front (not the back) of ER 1.121(d).
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. Interview S Paper No./ /08), 7. X Examiner's	formal Patent Application (PTO-152) ummary (PTO-413), /Mail Date <u>2/25/04</u> . Amendment/Comment Statement of Reasons for Allowance

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EXAMINER'S AMENDMENT

The application has been amended as follows:

In claim 52, line 13, after "are in the", insert – liquid.--.

Claims 10-19, 21-22 & 25-52 are allowed.

The following is an examiner's statement of reasons for allowance: the prior art does not teach that the center of the device electrode is not aligned with the center of the substrate electrode while the device is partially submerged in a liquid.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to M. Alexandra Elve whose telephone number is 571-272-1173. The examiner can normally be reached on 6:30-3:00 Monday to Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Dunn can be reached on 571-272-1171. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Examiner 5 Amendment.

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positioning said plurality of respective device electrodes so as to contact said opposite surface of said respective solder bumps such that the centers of said plurality of respective device electrodes are not aligned with the respective centers of said plurality of substrate electrodes while said device is at least partially submerged in said liquid;

aligning the centers of said plurality of respective device electrodes with the respective centers of said plurality of substrate electrodes by surface tension of said respective solder bumps when said respective solder bumps are melted and while said device is at least partially submerged in said liquid and at least partially supported by a buoyant force thereby joining said plurality of substrate electrodes and said plurality of respective device electrodes to each other; and

solidifying said respective solder bumps.

52. (Previously Presented) A method of joining a device to a substrate, the substrate having a plurality of solder pieces electrically coupled to a plurality of substrate electrodes, the method comprising:

placing the substrate in a liquid;

melting the plurality of solder pieces to form a plurality of solder bumps while the substrate is in the liquid;

placing a device having a plurality of respective device electrodes on the plurality of solder bumps while the device is in the liquid such that the plurality of respective device electrodes are out of alignment with a respective substrate electrode of the plurality of substrate electrodes; and

melting the plurality of solder bumps so as to cause the plurality of respective device electrodes to align with the plurality of respective substrate electrodes while the device and the substrate are in the $\frac{19}{3}$

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February 25, 2004.

M. ÁLEXÁNDRA ELVE PRIMARY EXAMINER